

INFORMATION DISCLOSURE CITATION
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Docket Number (Optional)

Application Number

81190-2502 MRW

Applicant(s)

Larry Hryshko

10/530868

Filing Date

Group Art Unit

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

U.S. PATENT APPLICATION PUBLICATIONS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		2002/064841	May 30/02	Mark A Reed et al.			

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
		02/29402	Apr. 11/02	WO				
		01/94939	Dec. 13/01	WO				
		01/48475	July 5/01	WO				
		02/64253	Aug 22/02	WO				

OTHER DOCUMENTS

(Including Author, Title, Date, Pertinent Pages, Etc.)

		Mosbacher J et al, "Studying Membranes With Scanning Force Microscopy and Patch-Clamp Technique", Journal of Vacuum Science and Technology: Part B, American Institute of Physics, vol. 14, no. 2, March 1, 1996, pages 1449-1452.

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.